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Dated: April 29, 2005

Signature:

(Michael R. Hull)

Docket No.: 29936/39510
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Young Hee Mun et al.

Application No.: 10/699,438

Confirmation No.: 3273

Filed: October 31, 2003

Art Unit: 2822

For: SILICON WAFER AND METHOD OF
FABRICATING THE SAME

Examiner: Maria F. Guerrero

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the second restriction requirement imposed in the office action mailed on April 19, 2005, applicants elect species A1 and respectfully submit that all elected claims 1-13 read thereon. Specifically, applicants respectfully submit that independent claims 1 and 8 both read on species A1 and an early action on the merits for all elected claims 1-13 is earnestly solicited.

The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 13-2855.

Dated: April 29, 2005

Respectfully submitted,

By
Michael R. Hull

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